**Hourly Use Rates for the Material Research Laboratory Facilities**

*Rates for researchers employed by the University of Illinois at Urbana-Champaign, other public sector employers, and companies located in the EnterpriseWorks Incubator at the University of Illinois Research Park.*

If you have any questions, please contact the MRL Business Office at 217-333-1372.

Rates valid from January 1, 2020 and are subject to change.

The rates listed below do not include overhead fees, such as Facilities and Administration, which will be added depending on your funding instrument or agreement.

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### Laser and Spectroscopy Facility

<table>
<thead>
<tr>
<th>Instrument</th>
<th>Technique</th>
<th>Self Use ($/hr)</th>
<th>Staff Assisted &amp; Training ($/hr)</th>
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<td>Custom Experiment</td>
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<td>Time-Domain Thermoreflectance, Custom Laser Experiments</td>
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<td>Montana Cryo Station</td>
<td>Closed He Cycle Optical Cryo Station</td>
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<td>Tip Enhanced Infrared Spectroscopy</td>
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<td>Newport Solar Simulator</td>
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<td>Zeiss LSM7 Confocal</td>
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Public Sector Rates (CY 2020 - Updated 1 February 2020)
# Micro & Nano-Fabrication Facility

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<th>Self Use ($/hr)</th>
<th>Staff Assisted &amp; Training ($/hr)</th>
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<td>Electron Beam Evaporation</td>
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<td>Jandel 4 Point Probe</td>
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<td>Tube Furnace - 6 inch</td>
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<td>Westbond Bonder</td>
<td>Wire Bonder</td>
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** Deposition of gold, platinum, or palladium incurs an additional charge of $4 per every 10 nm deposited or fraction thereof.
<table>
<thead>
<tr>
<th>Instrument</th>
<th>Technique</th>
<th>Self Use ($/hr)</th>
<th>Staff Assisted &amp; Training ($/hr)</th>
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<td>Bio-LM Sect</td>
<td>Trim &amp; LM Sectioning</td>
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<td>Bio-NegDevelop</td>
<td>Negative Development</td>
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<td>Bio-NegScan</td>
<td>Negative Scanning</td>
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<td>Bio-OptoMicro</td>
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<td>Reichart Ultracut</td>
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**Microscopy-Scanning Probe**

<table>
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<th>Technique</th>
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<tr>
<td>Hysitron Tip</td>
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**Microscopy-Scanning Electron**

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<tr>
<td>Hitachi S4700 SEM</td>
<td>Scanning Electron Microscopy/High Resolution</td>
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<td>Hitachi S4800 SEM</td>
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<td>JEOL 6060LV SEM</td>
<td>Scanning Electron Microscopy/Low Vacuum</td>
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<td>JEOL 7000F SEM</td>
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<td>Scios 2 FIB</td>
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**Microscopy-Transmission Electron**

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Public Sector Rates (CY 2020 - Updated 1 February 2020)
## Physical Property Measurement

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<td>Particle Size and Zeta Potential Measurements</td>
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## Surface Analysis

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<td>Vibratory Polisher 1</td>
<td>Vibratory Polisher</td>
<td>$3</td>
<td>$33</td>
</tr>
<tr>
<td>Vibratory Polisher 2</td>
<td>Vibratory Polisher</td>
<td>$3</td>
<td>$33</td>
</tr>
</tbody>
</table>

## X-ray Diffraction

<table>
<thead>
<tr>
<th>Instrument</th>
<th>Technique</th>
<th>Self Use ($/hr)</th>
<th>Staff Assisted &amp; Training ($/hr)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Dexcel Laue</td>
<td>X-ray Diffraction/Laue</td>
<td>$14</td>
<td>$44</td>
</tr>
<tr>
<td>Philips Xpert</td>
<td>X-Ray Diffraction/High Resolution, Point or Line Focus</td>
<td>$14</td>
<td>$44</td>
</tr>
<tr>
<td>SAXS</td>
<td>X-Ray Diffraction</td>
<td>$10</td>
<td>$40</td>
</tr>
<tr>
<td>Shimadzu EDXRF</td>
<td>X-Ray Fluorescence</td>
<td>$20</td>
<td>$50</td>
</tr>
<tr>
<td>Siemens-Bruker D5000 XRD</td>
<td>X-Ray Diffraction/Powder</td>
<td>$13</td>
<td>$43</td>
</tr>
</tbody>
</table>

## Support Equipment

<table>
<thead>
<tr>
<th>Instrument</th>
<th>Technique</th>
<th>Self Use ($/hr)</th>
<th>Staff Assisted &amp; Training ($/hr)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Allied Multiprep</td>
<td>TEM sample preparation</td>
<td>$6</td>
<td>$36</td>
</tr>
<tr>
<td>Carbon Rod Coater</td>
<td>SEM Carbon Coater</td>
<td>$10</td>
<td>$40</td>
</tr>
<tr>
<td>Carbon String Coater</td>
<td>SEM Carbon Coater</td>
<td>$10</td>
<td>$40</td>
</tr>
<tr>
<td>Dektak 3030</td>
<td>Surface Profilometry</td>
<td>$16</td>
<td>$46</td>
</tr>
<tr>
<td>FEI Vitrobot</td>
<td>Cryo-plunge for TEM sample preparation</td>
<td>$13</td>
<td>$43</td>
</tr>
<tr>
<td>Gatan CryoPIPS</td>
<td>Cryo-Ion Miller for TEM sample preparation</td>
<td>$10</td>
<td>$40</td>
</tr>
<tr>
<td>Gatan PECS II</td>
<td>Ion Miller for SEM sample preparation</td>
<td>$14</td>
<td>$44</td>
</tr>
<tr>
<td>Gatan PIPS</td>
<td>Ion Miller for TEM sample preparation</td>
<td>$10</td>
<td>$40</td>
</tr>
<tr>
<td>Leica EM UC6 Microtome</td>
<td>Microtome for TEM sample preparation</td>
<td>$17</td>
<td>$47</td>
</tr>
<tr>
<td>Princeton WS-25 Wire Saw</td>
<td>Wire Saw - High Precision</td>
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<td>$42</td>
</tr>
<tr>
<td>SEM Sputter Coater 1</td>
<td>SEM Sputter Coater</td>
<td>$12</td>
<td>$42</td>
</tr>
<tr>
<td>SEM Sputter Coater 2</td>
<td>SEM Sputter Coater</td>
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<td>$42</td>
</tr>
<tr>
<td>Tergeo EM Plasma Cleaner</td>
<td>Plasma Cleaner for TEM sample preparation</td>
<td>$12</td>
<td>$42</td>
</tr>
<tr>
<td>Vibratory Polisher 1</td>
<td>Vibratory Polisher</td>
<td>$3</td>
<td>$33</td>
</tr>
<tr>
<td>Vibratory Polisher 2</td>
<td>Vibratory Polisher</td>
<td>$3</td>
<td>$33</td>
</tr>
</tbody>
</table>

Public Sector Rates (CY 2020 - Updated 1 February 2020)